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**RESPONSE UNDER 37 C.F.R. §1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815**

**PATENT**  
**740756-1881**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re PATENT application of:**

Hongyong ZHANG, et al.

Application No.: 09/190,618

Filed: November 12, 1998

For: SEMICONDUCTOR DEVICE AND METHOD  
FOR FABRICATING THE SAME

) Art Unit: 2815

) Examiner: Eugene LEE

## REQUEST FOR RECONSIDERATION AFTER FINAL

Box AF  
Commissioner for Patents  
Washington, D.C. 20231

March 11, 2002

Dear Sir:

In response to the Examiner's final Office Action mailed December 11, 2001, please consider the following amendments and remarks in connection with the above-identified application.

## REMARKS

At the outset, the Examiner is thanked for the review and consideration of the present application.

The Examiner's final Office Action dated December 11, 2001 has been received and its contents reviewed. Claims 1-25 and 34-41 are pending in the present application.

Turning now to the Office Action, claims 1-4, 16, 19-22, 37, 38, and 41 are rejected under 35 U.S.C. § 102(e) as anticipated by Matsumoto (U.S. Patent No. 5,323,042). Further, claims 5 and 23 stand rejected under § 103(a) as unpatentable over Matsumoto in view of Dohjo

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